



**ELECTRONIC COPY**

LG779635842  
Report verification at igi.org



March 8, 2026

IGI Report Number **LG779635842**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.47 - 7.51 X 4.43 MM**

**GRADING RESULTS**

Carat Weight **1.51 CARAT**

Color Grade **F**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

March 8, 2026

IGI Report Number **LG779635842**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.47 - 7.51 X 4.43 MM**

**GRADING RESULTS**

Carat Weight **1.51 CARAT**

Color Grade **F**

Clarity Grade **VVS 2**

Cut Grade **EXCELLENT**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

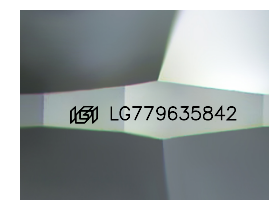
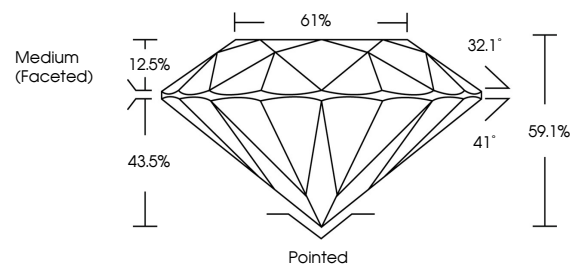
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG779635842**

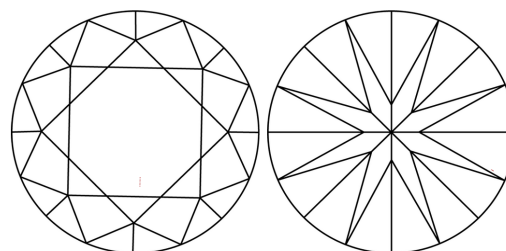
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

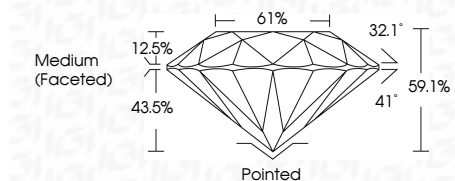
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG779635842**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



March 8, 2026	IGI Report No LG779635842	1.51 CARAT	F	VVS 2	EXCELLENT	61%	61%	Medium (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG779635842
ROUND BRILLIANT	7.47 - 7.51 X 4.43 MM	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa